Syllabus of magnetic thin films: film growth, characterization, and simulation

Wednesday 3:20-6:10pm(?) Spring 2018

Instructor: 歐陽淳厚(浩) (Office: M201/nano-alloy lab)

Purpose:

Comprehensive introduction to the field of magnetic films: Introduction to ferrimagnetism, film growth, characterization, and simulation

Reference book:

- 1. Materials Science of Thin Films, 2nd ed. by M. Ohring (Academic press, 歐亞書局 (02)8912-1188分機104),
- 2. Transmission Electron Microscopy & Diffraction of Materials, 3rd ed. by B. Fultz & J.M. Howe (Springer偉明圖書02-23638586),
- 3. Introduction to magnetic materials

by B.D. Cullity and C.D. Graham (2009)

4. Molecular Modelling/principles & applications, 2nd ed. by Andrew R. Leach

Outline:

- 1.Introduction
- 2. Vacuum science & technology1 (kinetic theory, transport & pumping)
- 3. Vacuum science & technology2 (vacuum pumps, vacuum systems)
- 4.**PVD** (physical vapor deposition: evaporation, sputtering, e.t.c.)
- 5.**CVD** (chemical vapor deposition: thermal CVD; plasma-enhanced CVD))
- 6.Practice
- 7. Film structure1 (structural morphology, computational simulations)
- 8.Film structure2 (grain growth, texture, microstructure controls in thin films;
- constrained film structures)
- 9.**Examine** (Midterm)
- 10. Introduction to ferrimagnetism (Magnetic anisotropy)
- 11. Introduction to ferrimagnetism (Domains and the magnetization process)
- 12. Introduction to ferrimagnetism (Domains and the magnetization process)
- 13. Introduction to ferrimagnetism (Domains and the magnetization process)
- 14. Introduction to ferrimagnetism (Domains and the magnetization process)
- 15.**HRTEM6** (general)
- 16. Simulations 1 (Monte Carlo simulations)
- 17. Simulations 2 (ab initio method: density functional theory)
- 18. Reports

Office hour: Mon. or Wed. 7:00pm

Grading: Midterm (45-50%), Presentation (45-50%), Homework (0-10%).

Teacher's Assistant: (C.-C. Chi, M218/Materials Science: Monday/7:00 pm).

(attainable website: http://moodle.nthu.edu.tw)